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Application Number		10570645		
Filing Date		2006-03-03		
First Named Inventor	Hilma	r Gugel	-	
Art Unit		2872		
Examiner Name	A, C,	Lavarias		
Attorney Docket Num	ber	20793/0204537-US0		
	Filing Date First Named Inventor Art Unit Examiner Name	Filing Date First Named Inventor Hilma Art Unit	Filing Date 2006-03-03 First Named Inventor Hilmar Gugel Art Unit 2872 Examiner Name A. C. Lavarias	

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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